Receipt date: 02/14/2008		105919	19 - GAU: 1 Page 1 of
SUPPLY MENT OF INFORMATION DISCLOSURE STATEMENT BY	Docket No. 52433/860 Applicant(s) TANIGUCHI et al.	Application No. 10/591,919  Examiner  Michael E. Lav	illa
APPLICANT PTO-1449	Filing Date September 6, 2006	Confirmation No. 5382	Art Unit

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

## FOREIGN PATENT DOCUMENTS

					SUBCLASS	TRANSLATION	
EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS		Yes	No
	EP 1 512 760 A2	March 9, 2005	EP				
	EP 1 707 645 A1	October 4, 2006	EP				
	JP 2000-345288 A	December 12, 2000	JP			Abstract	
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	JP 2001-207235 A	July 31, 2007	JP			Abstract	

EXAMINER	/Rebecca Lee/	DATE CONSIDERED	12/22/2009		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and					

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